

PREFACE	v
CONTENTS	xiii
COMMONLY USED SYMBOLS	xix
1. INTRODUCTION	1
1.1. The vacuum	1
1.1.1. <i>Artificial vacuum</i>	1
1.1.2. <i>Natural vacuum</i>	5
1.2. Fields of application and importance.	6
1.2.1. <i>Applications of vacuum techniques</i>	6
1.2.2. <i>Importance of vacuum technology</i>	10
1.3. Main stages in the history of vacuum techniques	11
1.4. Literature sources	13
1.4.1. <i>Books</i>	13
1.4.2. <i>Journals</i>	14
1.4.3. <i>Conference transactions</i>	15
1.4.4. <i>Visual and audio-visual aids</i>	16
2. RAREFIED GAS THEORY FOR VACUUM TECHNOLOGY	17
2.1. Physical states of matter	17
2.2. Perfect and real gas laws	23
2.2.1. <i>Boyle's law</i>	23
2.2.2. <i>Charles' law</i>	25
2.2.3. <i>The general gas law</i>	26
2.2.4. <i>Molecular density</i>	28
2.2.5. <i>Equation of state of real gases</i>	30
2.3. Motion of molecules in rarefied gases	33
2.3.1. <i>Kinetic energy of molecules</i>	33
2.3.2. <i>Molecular velocities</i>	34
2.3.3. <i>Molecular incidence rate</i>	36
2.4. Pressure and mean free path	37
2.4.1. <i>Mean free path</i>	37
2.4.2. <i>Pressure units</i>	40
2.5. Transport phenomena in viscous state	44
2.5.1. <i>Viscosity of a gas</i>	44
2.5.2. <i>Diffusion of gases</i>	47

2.6.	Transport phenomena in molecular states	50
2.6.1.	<i>The viscous and molecular states</i>	50
2.6.2.	<i>Molecular drag</i>	51
2.7.	Thermal diffusion and energy transport	53
2.7.1.	<i>Thermal transpiration</i>	53
2.7.2.	<i>Thermal diffusion</i>	55
2.7.3.	<i>Heat conductivity of rarefied gases</i>	56
3.	GAS FLOW AT LOW PRESSURES	62
3.1.	Flow regimes, conductance and throughput	62
3.1.1.	<i>Flow regimes</i>	62
3.1.2.	<i>Conductance</i>	64
3.1.3.	<i>Throughput and pumping speed</i>	67
3.2.	Viscous and turbulent flow	69
3.2.1.	<i>Viscous flow — conductance of an aperture</i>	69
3.2.2.	<i>Viscous flow — conductance of a cylindrical pipe</i>	72
3.2.3.	<i>Viscous flow — surface slip</i>	76
3.2.4.	<i>Viscous flow — rectangular cross section</i>	77
3.2.5.	<i>Viscous flow — annular cross section</i>	78
3.2.6.	<i>Turbulent flow</i>	79
3.3.	Molecular flow	80
3.3.1.	<i>Molecular flow — conductance of an aperture</i>	80
3.3.2.	<i>Molecular flow — conductance of a diaphragm</i>	81
3.3.3.	<i>Molecular flow — long tube of constant cross section</i>	82
3.3.4.	<i>Molecular flow — short tube of constant cross section</i>	86
3.4.	Conductance of combined shapes	88
3.4.1.	<i>Molecular flow — tapered tubes</i>	88
3.4.2.	<i>Molecular flow — elbows</i>	90
3.4.3.	<i>Molecular flow — traps</i>	91
3.4.4.	<i>Molecular flow — optical baffles</i>	96
3.4.5.	<i>Molecular flow — seal interface</i>	100
3.5.	Analytico—statistical calculation of conductances	103
3.6.	Intermediate flow	109
3.6.1.	<i>Knudsen's equation</i>	109
3.6.2.	<i>The minimum conductance</i>	112
3.6.3.	<i>The transition pressure</i>	114
3.6.4.	<i>Limits of the intermediate range</i>	115
3.6.5.	<i>General equation of flow</i>	116
3.6.6.	<i>The molecular—viscous intersection point</i>	117
3.6.7.	<i>Integrated equation of flow</i>	119
3.7.	Calculation of vacuum systems.	123
3.7.1.	<i>Source of gas in vacuum systems</i>	123

3.7.2.	<i>Pumpdown in the viscous range</i>	125
3.7.3.	<i>Pumpdown in the molecular range</i>	128
3.7.4.	<i>Steady state with distributed gas load</i>	131
3.7.5.	<i>Nomographic calculation of conductances and pumpdown time</i>	134
3.7.6.	<i>Evaluation of the gas load and pumping requirements.</i>	139
4.	PHYSICO-CHEMICAL PHENOMENA IN VACUUM TECHNIQUES.	149
4.1.	Evaporation—condensation	149
4.1.1.	<i>Vapours in vacuum systems</i>	149
4.1.2.	<i>Vapour pressure and rate of evaporation</i>	150
4.1.3.	<i>Vapour pressure data</i>	152
4.1.4.	<i>Cryopumping and vacuum coating</i>	156
4.2.	Solubility and permeation.	163
4.2.1.	<i>The permeation process</i>	163
4.2.2.	<i>Permeation through vacuum envelopes</i>	166
4.2.3.	<i>Consequences of permeation</i>	169
4.3.	Sorption	172
4.3.1.	<i>Sorption phenomena</i>	172
4.3.2.	<i>Adsorption energies</i>	172
4.3.3.	<i>Monolayer and sticking coefficient</i>	175
4.3.4.	<i>Adsorption isotherms.</i>	178
4.3.5.	<i>True surface</i>	180
4.3.6.	<i>Sorption of gases by adsorbents</i>	182
4.4.	Desorption—outgassing.	185
4.4.1.	<i>Desorption phenomena.</i>	185
4.4.2.	<i>Outgassing</i>	186
4.4.3.	<i>Outgassing rates</i>	190
4.5.	Interaction of electrons and ions with surfaces	193
4.5.1.	<i>Electron scattering.</i>	193
4.5.2.	<i>Ion scattering</i>	194
4.5.3.	<i>Low energy electron diffraction (LEED)</i>	196
4.5.4.	<i>Auger electron spectroscopy (AES).</i>	198
5.	PRODUCTION OF LOW PRESSURES	200
5.1.	Vacuum pumps.	200
5.1.1.	<i>Principles of pumping.</i>	200
5.1.2.	<i>Parameters and classifications</i>	200
5.2.	Mechanical pumps.	203
5.2.1.	<i>Liquid pumps</i>	203
5.2.2.	<i>Piston pumps</i>	204
5.2.3.	<i>Water ring pumps</i>	205
5.2.4.	<i>Rotating-vane pumps</i>	206

5.2.5.	<i>Sliding-vane pumps</i>	212
5.2.6.	<i>Rotating-plunger pumps</i>	214
5.2.7.	<i>Root's pumps</i>	215
5.2.8.	<i>Molecular pumps</i>	217
5.3.	<i>Vapour pumps</i>	220
5.3.1.	<i>Classification</i>	220
5.3.2.	<i>Vapour ejector pumps</i>	221
5.3.3.	<i>Diffusion pumps</i>	222
5.4.	<i>Ion pumps</i>	232
5.4.1.	<i>Classification</i>	232
5.4.2.	<i>Ion pumping</i>	232
5.4.3.	<i>Evapor-ion pumps</i>	234
5.4.4.	<i>Sputter-ion pumps</i>	237
5.5.	<i>Sorption pumps</i>	242
5.5.1.	<i>Nature of sorption pumping</i>	242
5.5.2.	<i>The sorption pump</i>	244
5.5.3.	<i>Multistage sorption pumping</i>	246
5.6.	<i>Cryopumping</i>	248
5.6.1.	<i>Cryopumping mechanism</i>	248
5.6.2.	<i>Cryopumping arrays</i>	254
5.6.3.	<i>Cryotrapping</i>	257
5.6.4.	<i>Cryopumps</i>	258
5.6.5.	<i>Liquid nitrogen traps</i>	260
5.7.	<i>Gettering</i>	263
5.7.1.	<i>Gettering principles</i>	263
5.7.2.	<i>Flash getters</i>	265
5.7.3.	<i>Bulk and coating getters</i>	267
5.7.4.	<i>Gettering capacity</i>	269
5.7.5.	<i>Sublimation pumps</i>	270
5.8.	<i>Pumping by dilution</i>	271
5.9.	<i>Measurement of pumping speed</i>	272
5.9.1.	<i>Methods of measurement</i>	272
5.9.2.	<i>Constant pressure methods</i>	272
5.9.3.	<i>Constant volume method</i>	275
5.9.4.	<i>Measurement of the pumping speed of mechanical and diffusion pumps</i>	275
5.9.5.	<i>Measurement of the pumping speed of sputter-ion pumps</i>	278
6.	MEASUREMENT OF LOW PRESSURES	280
6.1.	<i>Classification and selection of vacuum gauges</i>	280
6.2.	<i>Mechanical gauges</i>	282
6.2.1.	<i>Bourdon gauge</i>	282

6.2.2.	<i>Diaphragm gauges</i>	283
6.3.	Gauges using liquids.	285
6.3.1.	<i>U-tube manometers</i>	285
6.3.2.	<i>Inclined manometers</i>	286
6.3.3.	<i>Differential manometers</i>	287
6.3.4.	<i>The Dubrovin gauge</i>	287
6.3.5.	<i>The McLeod gauge</i>	289
6.4.	Viscosity (molecular) gauges	298
6.4.1.	<i>Principles</i>	298
6.4.2.	<i>The decrement gauge</i>	298
6.4.3.	<i>The rotating molecular gauge</i>	299
6.4.4.	<i>The resonance type viscosity gauge</i>	301
6.5.	Radiometer (Knudsen) gauge	301
6.6.	Thermal conductivity gauges	304
6.6.1.	<i>Thermal conductivity and heat losses</i>	304
6.6.2.	<i>Pirani gauge</i>	305
6.6.3.	<i>The thermocouple gauge</i>	307
6.6.4.	<i>The thermistor gauge</i>	309
6.6.5.	<i>Combined McLeod–Pirani gauge</i>	310
6.7.	Ionization gauges.	310
6.7.1.	<i>The discharge tube</i>	310
6.7.2.	<i>Hot-cathode ionization gauges</i>	311
6.7.3.	<i>Cold-cathode ionization gauges</i>	321
6.7.4.	<i>Gauges with radioactive sources</i>	324
6.8.	Calibration of vacuum gauges.	325
6.8.1.	<i>General</i>	325
6.8.2.	<i>McLeod gauge method</i>	325
6.8.3.	<i>Expansion method</i>	326
6.8.4.	<i>Flow method</i>	326
6.8.5.	<i>Pumpdown method</i>	327
6.9.	Partial pressure measurement	328
6.9.1.	<i>General</i>	328
6.9.2.	<i>Magnetic deflection mass spectrometers</i>	328
6.9.3.	<i>The trochoidal (or cycloidal) mass spectrometer</i>	331
6.9.4.	<i>The omegatron</i>	332
6.9.5.	<i>The Farvitron</i>	333
6.9.6.	<i>Quadrupole and monopole mass spectrometers</i>	334
6.9.7.	<i>Time-of-flight mass spectrometers</i>	335
7.	HIGH VACUUM TECHNOLOGY	337
7.1.	Criteria for selection of materials	337
7.1.1.	<i>General</i>	337

7.1.2.	<i>Mechanical strength</i>	337
7.1.3.	<i>Permeability to gases</i>	339
7.1.4.	<i>Vapour pressure and gas evolution</i>	339
7.1.5.	<i>Working conditions</i>	339
7.1.6.	<i>Metal vessels and pipes</i>	339
7.1.7.	<i>Glass vessels and pipes</i>	341
7.1.8.	<i>Elastomer and plastic pipes</i>	342
7.2.	<i>Cleaning techniques</i>	344
7.2.1.	<i>Cleaning of metals</i>	344
7.2.2.	<i>Cleaning of glass</i>	349
7.2.3.	<i>Cleaning of ceramics</i>	350
7.2.4.	<i>Cleaning of rubber</i>	350
7.2.5.	<i>Baking</i>	351
7.3.	<i>Sealing techniques</i>	351
7.3.1.	<i>General, classifications</i>	351
7.3.2.	<i>Permanent seals</i>	352
7.3.3.	<i>Semipermanent and demountable seals</i>	383
7.3.4.	<i>Gasket seals</i>	395
7.3.5.	<i>Electrical lead-throughs</i>	419
7.3.6.	<i>Motion transmission</i>	423
7.3.7.	<i>Material transfer into vacuum systems</i>	429
7.4.	<i>Leak detection</i>	439
7.4.1.	<i>Leak rate and detection</i>	439
7.4.2.	<i>Leakage measurement</i>	443
7.4.3.	<i>Leak location</i>	451
7.4.4.	<i>Sealed unit testing</i>	453
7.4.5.	<i>Sensitive leak detection methods</i>	455
7.5.	<i>Rules for operating vacuum systems</i>	462
REFERENCES		464
SUBJECT INDEX		538